

<b>Notice of References Cited</b>	Application/Control No. 10/618,756	Applicant(s)/Patent Under Reexamination TANAKA, TOYOHICO	
	Examiner Otilia Gabor	Art Unit 2878	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,703,689	12-1997	Powell, Ronald Allan	356/432
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 10-253454	09-1998	JAPAN		G01J 3/45
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	"FTIR DEDICATED 2-13 MICROMETER PHOTOCONDUCTOR THERMOELECTRICALLY COOLED OPTICALLY IMMERSED" - SYSTEMS S.A.; 16.08.2005
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.